

Electronic Patent Application Fee Transmittal

Application Number:	10779397			
Filing Date:	13-Feb-2004			
Title of Invention:	Substrate processing apparatus and substrate processing method			
First Named Inventor/Applicant Name:	Naoki Shindo			
Filer:	David Tai-Wei Yang/Deanna Fintz			
Attorney Docket Number:	199372003910			

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Extension - 3 months with \$490 paid	1253	1	620	620
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1430